

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of ) Attorney Docket No.: **ASA1N0189**  
Tomoyuki WATANABE et al. )  
Serial No.: 10/598,961 ) Confirmation No.: 2626  
Filed: September 15, 2006 ) Group Art Unit: 2812  
For: METHOD FOR MANUFACTURING ) Examiner: Savitri MULPURI  
SEMICONDUCTOR DEVICE ) Date: August 3, 2009

### **AMENDMENT (C)**

**MAIL STOP: AMENDMENT**

United States Patent and Trademark Office  
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Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

In response to the interview conducted between Applicants' counsel, Joerg Szipl, and Examiner, Savitri Mulpuri on July 24, 2009, please enter Applicants' remarks in the above-captioned application as follows.

**Amendment to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.